



Applicant:

Tadahiro OHMI et al.

Title:

SHOWER PLATE, PLASMA PROCESSING APPARATUS, AND

PRODUCT MANUFACTURING METHOD

Appl. No.:

10/584,340

International

09/24/2004

Filing Date:

371(c) Date:

08/02/2006

Examiner:

Keath T. Chen

Art Unit:

1792

Confirmation

2005

Number:

AMENDMENT AND REPLY UNDER 37 C.F.R. § 1.111

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated December 1, 2009, concerning the above-referenced patent application.

Applicants have included payment for three-month extension of to make this response timely.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: